



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Hans-Stephan Albrecht, et al

Application No.: 09/903,425

Filed: July 10, 2001

For: PRECISE MONITOR ETALON
CALIBRATION TECHNIQUE

Confirmation No.: 8935

Group Art Unit: 2828

Examiner: Hung T. Vy

**COMMENTS ON STATEMENT OF
REASONS FOR ALLOWANCE**353 Sacramento Street, Suite 2200
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on July 2, 2004.
STALLMAN & POLLOCK LLP

Dated: 07/2/2004

By:

Georgia K. Stith
Georgia K. Stith

Sir:

In response to the Notice of Allowability for above-referenced matter, Applicants note with appreciation the indication that claims 1-19 are allowed.

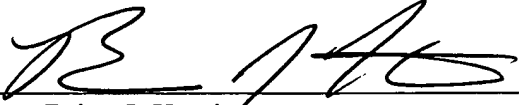
It is further noted that the Notice of Allowability includes a statement of "Reasons for Allowance". The Reasons for Allowance includes certain language which is not included in all of the allowed claims. For example, the Reasons for Allowance refers to "adjusting the wavelength of the laser beam to the target wavelength when the compensated wavelength differs from the target wavelength". It is respectfully submitted that not all of the allowed independent claims recite this operation. Thus, it is respectfully submitted that each of the individual claims should be interpreted according to the specific language recited in each of the respective claims,

and that all the elements recited in the Examiner's Reasons for Allowance should not be read into all the allowed claims.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: July 2, 2004

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